



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of:  
Shing-Chyang Pan

Serial No.: 10/789,660

Filed: 04/09/2003

Confirmation Number: 7563

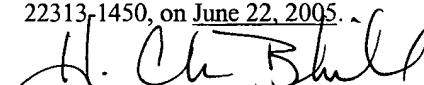
Group Art Unit: 1763  
Examiner: Arancibia, Maureen

TKHR Docket No. 252016-2960  
Top-Team Ref. 0503-A30494US

For: **PRE-CLEAN CHAMBER WIH WAFER HEATING APPARATUS AND METHOD OF USE**

**Certificate of Mailing**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Mail Stop Amendment; Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on June 22, 2005.

  
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Signature – Hui Chin Barnhill

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

Mail Stop Amendment  
Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The non-final Office Action mailed February 22, 2005 has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.